

Notice of References Cited	Application/Control No. 10/675,790	Applicant(s)/Patent Under Reexamination JARABEK ET AL.	
	Examiner Hong C. Kim	Art Unit 2185	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,998,242	03-1991	Upp, Daniel C.	370/392
*	B	US-5,872,780	02-1999	Demiray et al.	370/359
*	C	US-5,917,818	06-1999	Ko et al.	370/377
*	D	US-6,356,550	03-2002	Williams, Kevin Wayne	370/364
*	E	US-2005/0068988	03-2005	Jarabek et al.	370/506
*	F	US-2005/0068991	03-2005	Jarabek et al.	370/516
*	G	US-2005/0071718	03-2005	Jarabek et al.	714/736
*	H	US-5,914,952	06-1999	Eom et al.	370/369
*	I	US-6,449,292	09-2002	Weeber, William B.	370/517
*	J	US-6,674,714	01-2004	Mochizuki et al.	370/217
*	K	US-2003/0053494	03-2003	Mochizuki, Hideaki	370/539
*	L	US-2004/0100994	05-2004	Miller, Glen W.	370/503
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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